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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Katsuto TANAHASHI et al.**

Group Art Unit: **3663**

Application Number: **10/743,793**

Examiner: **Johannes P. Mondt**

Filed: **December 24, 2003**

Confirmation Number: **9788**

For: **SEMICONDUCTOR SUBSTRATE AND MANUFACTURING
METHOD THEREOF**

Attorney Docket Number: **032206**
Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.116
EXPEDITED PROCESSING REQUESTED

MAIL STOP AF

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

November 21, 2006

Sir:

In response to the Office Action dated July 21, 2006, the response date of which having been extended by one month to November 21, 2006, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.